

Title (en)

SUBSTRATE WASHING DEVICE AND PROCESS

Title (de)

SUBSTRATWASCHVORRICHTUNG UND -VERFAHREN

Title (fr)

DISPOSITIF ET PROCÉDÉ DE LAVAGE DE SUBSTRAT

Publication

**EP 3212834 A1 20170906 (EN)**

Application

**EP 15784390 A 20151023**

Priority

- EP 14190431 A 20141027
- EP 2015074597 W 20151023

Abstract (en)

[origin: WO2016066543A1] A washing device for manual washing of a substrate, the washing device comprising: a) a receptacle for containing an aqueous wash liquor with a substrate at least partially immersed therein; b) a filling and access aperture defined by upper peripheral edge portion/s of the washing receptacle; and c) at least one upper portion of the device which is transparent or translucent.

IPC 8 full level

**D06F 1/00** (2006.01)

CPC (source: CN EP)

**A47L 17/00** (2013.01 - CN); **B08B 3/006** (2013.01 - CN); **D06F 1/00** (2013.01 - EP); **D06F 1/04** (2013.01 - CN)

Citation (search report)

See references of WO 2016066543A1

Citation (examination)

- EP 1676947 A1 20060705 - ANGELOPOULOS EFTHIMIOS [GR]
- JP 2003117289 A 20030422 - EGASHIRA KIYOUKO

Designated contracting state (EPC)

AL AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HR HU IE IS IT LI LT LU LV MC MK MT NL NO PL PT RO RS SE SI SK SM TR

Designated extension state (EPC)

BA ME

DOCDB simple family (publication)

**WO 2016066543 A1 20160506**; AR 102437 A1 20170301; BR 112017008750 A2 20171219; CL 2017001014 A1 20171110; CN 107148318 A 20170908; EP 3212834 A1 20170906

DOCDB simple family (application)

**EP 2015074597 W 20151023**; AR P150103471 A 20151027; BR 112017008750 A 20151023; CL 2017001014 A 20170424; CN 201580058820 A 20151023; EP 15784390 A 20151023